



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 8109

SERIAL NUMBER 10/809,712	FILING OR 371(c) DATE 03/26/2004 RULE	CLASS 428	GROUP ART UNIT 1775	ATTORNEY DOCKET NO. 12054-0025
------------------------------------	---	---------------------	-------------------------------	--

APPLICANTS
 Hideshi Nishikawa, Tokyo, JAPAN;
 Nobumitsu Takase, Tokyo, JAPAN;
 Kazuyuki Egashira, Tokyo, JAPAN;
 Hiroshi Hayakawa, Tokyo, JAPAN;

**** CONTINUING DATA ******* *none TMS*

**** FOREIGN APPLICATIONS ******* *yes TMS*
 JAPAN 2003-097665 04/01/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
**** 06/10/2004**

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 3	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>TMS</i>	Initials		

ADDRESS
22902

TITLE
Silicon annealed wafer and silicon epitaxial wafer

FILING FEE RECEIVED 856	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees (Filing)
		<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
		<input type="checkbox"/> 1.18 Fees (Issue)
		<input type="checkbox"/> Other _____
		<input type="checkbox"/> Credit